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LIST OF ARTS CITED BY APPLICANT

(Draw several sheets if necessary)

APPLICANT
Micron Technology, Inc.FILING DATE
October 26, 1999GROUP
2825

U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
KR	AA	4,333,808	6/8/82	Bhattacharyya et al.			
↓	AB	5,585,300	12/17/96	Summerfelt			
↓	AC	5,641,702	6/24/97	Imai et al.			
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
KR	AL	JP 405,343,641 (Shimada)	12/1993	Japan	257	310		
	AM							
	AN							
	AO							
	AP							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

AR		H. Shinriki and M. Nakata, IEEE Transaction On Electron Devices vol 38 No 3 March 1991
AS		
AT		

EXAMINER

K. J. Rose

DATE CONSIDERED

10/9/01

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.